

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of )  
Shinji MAEKAWA )  
Japanese Priority Application No. 2002-303659 ) Attn: Applications  
Japanese Priority Date: October 17, 2002 ) Branch  
For: METHOD OF MANUFACTURING )  
SEMICONDUCTOR DEVICE ) Date: October 16, 2003

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

Japanese Patent Application Laid-Open No. 07-130652 is in the same family as U.S. Patents 5,643,826 and 5,923,962 and European Patent 0 651 431 A2.

Japanese Patent Application Laid-Open No. 07-161634 is in the same family as U.S. Patents 5,543,352 and 5,612,250.

Japanese Patent Application Laid-Open No. 2001-345453 is in the same family as U.S. Patent Application Publication No. US2001/0052950 A1.

Japanese Patent Application Laid-Open No. 2001-85703 is in the same family as U.S. Patent 6,426,245 B1 and U.S. Publication No. US2002/0146874A1.

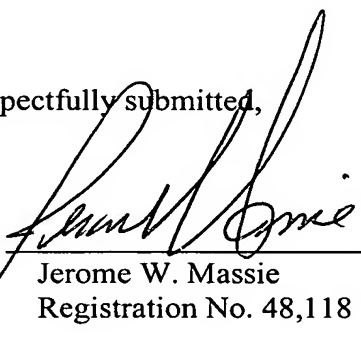
Japanese Patent Application Laid-Open No. 08-228006 is in the same family as U.S. Patent 5,953,597.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the

documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

By:

  
Jerome W. Massie  
Registration No. 48,118

NIXON PEABODY LLP  
401 9<sup>th</sup> Street, N.W.  
Suite 900  
Washington, D.C. 20004-2128  
  
(202) 585-8000

Substitute for form 1449A/PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>				<b>Complete if Known</b>		
				Application Number		New Application
				Filing Date		October 16, 2003
				First Named Inventor		Shinji MAEKAWA
				Art Unit		
Examiner Name						
Sheet	1	of	1	Attorney Docket Number		740756-2660

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code <sup>2</sup> (if known)			
		US-5,643,826	07/01/1997	Ohtani et al.	
		US-5,923,962	07/13/1999	Ohtani et al.	
		US-5,543,352	08/06/1996	Ohtani et al.	
		US-5,612,250	03/18/1997	Ohtani et al.	
		US-2001/0052950 A1	12/20/2001	Yamazaki et al.	
		US-6,426,245 B1	07/30/2002	Kawasaki et al.	
		US-2002/0146874 A1	10/10/2002	Kawasaki et al.	
		US-5,953,597	09/14/1999	Kusumoto et al.	
		US-5,612,251	03/18/1997	Lee	
		US-5,767,003	07/16/1998	Noguchi	
		US-5,953,597	09/14/1999	Kusumoto et al.	
		US-6,020,224	02/01/2000	Shimogaichi et al.	
		US-6,246,524 B1	06/12/2001	Tanaka	
		US-6,248,606 B1	06/19/2001	Ino et al.	
		US-6,380,009 B1	04/30/2002	Battersby	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)				
		JP 07-130652	05/19/1995	Otani et al.		Abstract
		EP 0 651 431 A2	05/03/1995	Ohtani et al.		Full
		JP 07-161634	06/23/1995	Otani et al.		Abstract
		JP 2001-345453	12/14/2001	Yamazaki et al.		Abstract
		JP2001-85703	03/30/2001	Kawasaki et al.		Abstract
		JP 08/228006	09/03/1996	Kusumoto et al.		Abstract

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		Kazuhiro SHIMIZU et al., "High-Mobility Poly-Si Thin-Film Transistors Fabricated by a Novel Excimer Laser Crystallization Method", IEEE TRANSACTIONS ON ELECTRON DEVICES., VOL. 40, NO. 1, pp. 112-117.	

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.